



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BOARD OF PATENT APPEALS AND INTERFERENCES

Applicant(s): Franz LAERMER et al.

Serial No.: 09/720,761

Group Art Unit: 1765

Filing Date: March 26, 2001

Examiner: Kin Chan Chen

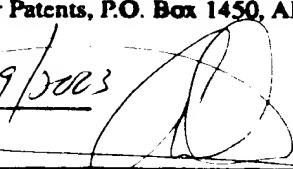
For: **METHOD OF PLASMA
ETCHING OF SILICON**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Mail Stop APPEAL BRIEF - PATENTS

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450
on

Date: 9/29/2003

Signature: 

**AARON C. DEDITCH
(33,865)**

Address to:
Mail Stop Appeal Brief - Patents
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

**APPEAL BRIEF TRANSMITTAL
AND PETITION TO EXTEND**

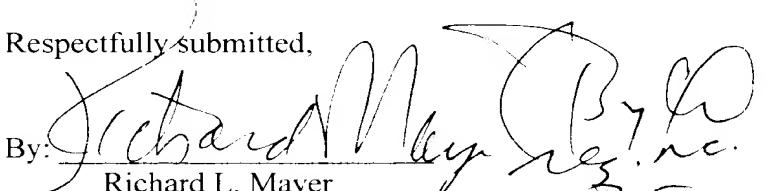
SIR:

Accompanying this Appeal Brief Transmittal is an Appeal Brief pursuant to 37 C.F.R. § 1.192(a) **in triplicate** for filing in the above-identified patent application.

This is also a **Petition To Extend** Under 37 C.F.R. § 1.136(a) to extend the two-month response date by one **(1) month** from the two-month date (which is at least July 10, 2003) to at least October 10, 2003.

Please charge the appropriate fees of \$430.00, which includes the Appeal Brief fee under 37 C.F.R. § 1.17(c) (which is believed to be \$320.00) and the Rule 136(a) extension fee (which is believed to be \$110.00 for a one-month extension), to Deposit Account No. **11-0600**. The Commissioner is also authorized, as necessary and/or appropriate, to charge any additional and appropriate fees, including any further Rule 136(a) extension fees, or credit any overpayment to Deposit Account No. **11-0600**. Two duplicate copies of this transmittal are enclosed for that purpose.

Respectfully submitted,

By: 
Richard L. Mayer

Richard L. Mayer
(Reg. No. 22,490)

Dated: 9/29/2003

KENYON & KENYON
One Broadway
New York, New York 10004
(212) 425-7200

CUSTOMER NO. 26646